

<b>Notice of References Cited</b>	Application/Control No. 09/589,217	Applicant(s)/Patent Under Reexamination COOPER, DAVID	
	Examiner Huy Q Phan	Art Unit 2687	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,940,761 A	08-1999	Tiedemann et al.	455/437
	B	US-6,223,030 B1	04-2001	Van Den Heuvel et al.	455/435.2
	C	US-6,272,315 B1	08-2001	Chang et al.	455/13.1
	D	US-6,584,116 B1	06-2003	Gourgue et al.	370/442
	E	US-5,917,811 A	06-1999	Weaver et al.	370/332
	F	US-5,826,188 A	10-1998	Tayloe et al.	455/428
	G	US-6,792,283 B1	09-2004	Roberts et al.	455/525
	H	US-2002/0045447 A1	04-2002	Rasanen, Juha	455/436
	I	US-6,377,804 B1	04-2002	Lintulampi, Raino	455/435.2
	J	US-6,311,054 B1	10-2001	Korpela, Mikko	455/406
	K	US-6,208,857 B1	03-2001	Agre et al.	455/428
	L	US-5,734,980	03-1998	Hooper et al.	455/434
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.